



Docket No. P0284US-7

ZFW
PATENT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: LI et al.

Examiner: Tran

Serial No. 10/676,953

Group Art Unit: 2826

Filed: September 30, 2003

Title: LIGHT EMITTING DIODE WITH POROUS SIC SUBSTRATE AND METHOD FOR FABRICATING

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**TRANSMITTAL FOR
SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

Sir:

Transmitted herewith is Supplemental Information Disclosure Statement for this application and a PTO Form 1449 citing the U.S patent references.

If any additional fee is required, the Commissioner is authorized to charge Deposit Account No. 11-1580. A duplicate of this transmittal is attached.

Respectfully submitted,

Dated: 6/15/05



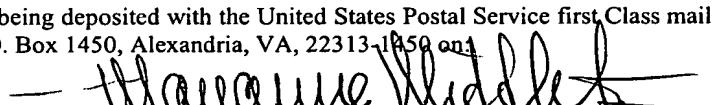
Jaye G. Heybl
Registration No. 42,661
Attorney for Applicant

KOPPEL, JACOBS, PATRICK & HEYBL
555 St. Charles Drive, Suite 107
Thousand Oaks, California, 91360
Telephone: (805) 373-0060

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service first Class mail addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA, 22313-1450 on

Date: 6/16/05



Marianne Middleton

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: LI et al.

JUN 20 2003 Serial No.10/676,953

Filed: September 30, 2003

Title: LIGHT EMITTING DIODE WITH POROUS SiC SUBSTRATE AND METHOD FOR FABRICATING

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

This certification is being made for this Supplemental Information Disclosure Statement. Applicants submit a copy of each of the non-U.S. patent references listed on the attached PTO-1449 (Modified) form for consideration by the Examiner.

I, the person signing below certify that:

(a) each item of information contained in the supplemental information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the supplemental information disclosure statement (37 C.F.R. § 1.97(e)(1)); or

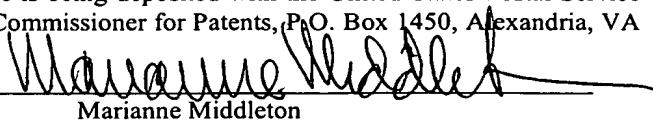
(b) no item of information contained in the supplemental information disclosure statement, to the knowledge of the person signing the certification after making reasonable inquiry, was known to any individual designated in § 1.56(c) more than three months prior to the filing of the statement. 37 C.F.R. § 1.97(e)(2).

This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that each or all of the listed documents are material or constitute "prior art". If the Examiner applies any of the documents as prior art against any claim in the application and applicants determine that the cited documents do not constitute "prior art" under United States law, applicants reserve the right to present to the

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

6/16/05
Date


Marianne Middleton

Office the relevant facts and law regarding the appropriate status of such documents.

Respectfully submitted,



Jaye G. Heybl
Registration No. 42,661
Attorney for Applicant

June 14, 2005

KOPPEL, JACOBS, PATRICK & HEYBL
555 St. Charles Drive, Suite 107
Thousand Oaks, California 91360
(805) 373-0060

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

Date

Marianne Middleton

FORM PTO-1449 (Modified)	Docket No. P0284US-7	Application Number 10/676,953
INFORMATION DISCLOSURE CITATION IN AN APPLICATION	Applicant LI et al.	
JUN 20 2003 (Use several sheets if necessary)	Filing Date September 30, 2003	Group Art Unit 2826

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	1	US 2001/010449 A1 (CHIU CHIEN-CHIA et al) AUGUST 2, 2001.
	2	LAGOUBI, A. et al. "CONDITIONING OF N-SILICON BY PHOTOLECTROCHEMICAL ETCHING FOR PHOTOVOLTAIC APPLICATIONS" PROC. OF THE 11 TH E.C. PHOTOVOLTAIC SOLAR ENERGY CONFERENCE, OCTOBER 12, 1992-OCTOBER 16, 1992, pp. 250-253, XP008043956pp 252-253 Figure 8.
	3	PATENT ABSTRACTS OF JAPAN, 07007179, 10-01-95, SANYO ELECTRIC CO LTD, "LIGHT EMITTING ELEMENTZ"

Examiner	Date Considered
----------	-----------------

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.